

(19) World Intellectual Property
Organization
International Bureau



(43) International Publication Date
23 June 2005 (23.06.2005)

PCT

(10) International Publication Number
WO 2005/057235 A1

(51) International Patent Classification⁷: **G01T 1/20**

(21) International Application Number:
PCT/IB2004/052640

(22) International Filing Date: 2 December 2004 (02.12.2004)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:
03104598.2 9 December 2003 (09.12.2003) EP

(71) Applicant (for DE only): **PHILIPS INTELLECTUAL
PROPERTY & STANDARDS GMBH** [DE/DE]; Stein-
damm 94, 20099 Hamburg (DE).

(71) Applicant (for AE, AG, AL, AM, AT, AU, AZ, BA, BB, BE,
BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CY, CZ,

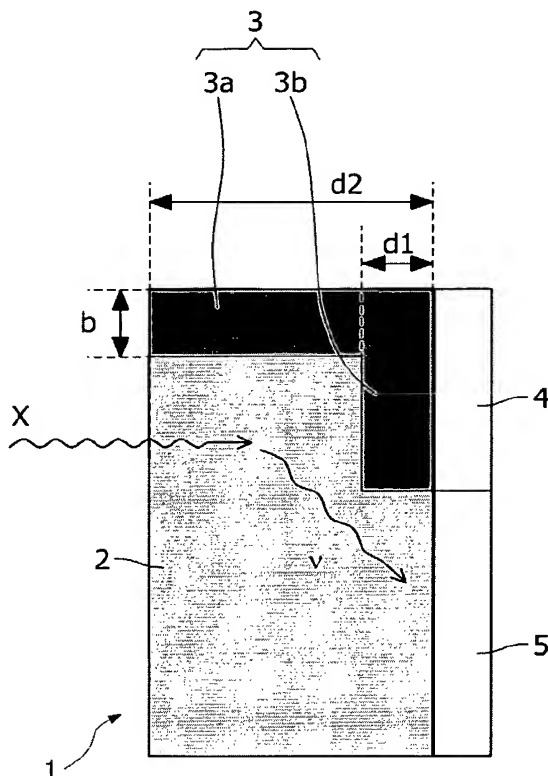
DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM,
HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK,
LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ,
NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD,
SE, SG, SK, SL, SY, SZ, TJ, TM, TN, TR, TT, TZ, UA, UG,
UZ, VC, VN, YU, ZA, ZM, ZW only): **KONINKLIJKE
PHILIPS ELECTRONICS N. V.** [NL/NL]; Groenewoud-
seweg 1, NL-5621 BA Eindhoven (NL).

(72) Inventors; and

(75) Inventors/Applicants (for US only): **VOGTMEIER,
Gereon** [DE/DE]; c/o Philips Intellectual Property &
Standards GmbH Weissshausstr. 2, 52066 Aachen (DE).
STEADMAN, Roger [ES/DE]; c/o Philips Intellec-
tual Property &, Standards GmbH Weissshausstr. 2,
52066 Aachen (DE). **ENGEL, Klaus Jürgen** [DE/DE];
c/o Philips Intellectual Property &, Standards GmbH
Weissshausstr. 2, 52066 Aachen (DE). **WIECZOREK,
Herfried** [DE/DE]; c/o Philips Intellectual Property &

[Continued on next page]

(54) Title: SHIELDING FOR AN X-RAY DETECTOR



(57) Abstract: The invention relates to an X-ray detec-
tor with detector elements (1) arranged in a layer. The de-
tector elements (1) contain a scintillator element (2) for
the conversion of X-rays (X) into photons (v), a photodi-
ode (5) for detection of the photons (v), and a processing
circuit (4) for the processing of electric signals gener-
ated by the photodiode (5). In order to protect the elec-
tronics (4) from X-rays a shielding (3) of variable effective
thickness (d1, d2) is disposed in front of the electronics
(4). This shielding (3) can in particular be L-shaped. By
reduction of the effective thickness of the shielding (3) to
a necessary minimum the volume of the scintillator unit
(2) can be maximized.

WO 2005/057235 A1



Standards GmbH Weissshausstr. 2, 52066 Aachen (DE).
ECKENBACH, Wolfgang [DE/DE]; c/o Philips Intellectual Property &, Standards GmbH Weissshausstr. 2, 52066 Aachen (DE).

(74) **Agents:** **VOLMER, Georg** et al.; Philips Intellectual Property &, Standards GmbH Weissshausstr. 2, 52066 Aachen (DE).

(81) **Designated States** (*unless otherwise indicated, for every kind of national protection available*): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM,

TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.

(84) **Designated States** (*unless otherwise indicated, for every kind of regional protection available*): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Published:

— with international search report

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

Shielding for an X-ray detector

5 The invention relates to an X-ray detector with detector elements arranged in a layer, wherein every detector element comprises a sensor unit and a shielded processing circuit coupled thereto.

 An X-ray detector of the kind mentioned above may for example be employed in a CT-device. The individual detector elements of such an X-ray detector
10 each generate the image signal of one picture element (pixel). Due to the arrangement of processing circuits in every pixel it is necessary to protect the electronics from interference and damage by incident X-rays. This protection may be achieved by a grid-shaped shielding made of lead or another suitable material disposed in front of the processing circuits.

15

 Furthermore, an X-ray detector is known from the WO 03/044563 A1 where electronic circuits arranged next to an array of photo sensors are shielded by coverings of lead and by a collimator arranged above the sensor array.

20

 It was an object of the present invention to provide an improved X-ray detector of the kind mentioned above with integrated electronics in the pixel which shows a higher sensitivity.

25 This task is solved based on a new approach to shielding issues by an X-ray detector with the features of claim 1 or 12. Preferred embodiments are subject to the dependent claims.

 The X-ray detector in accordance with the invention comprises detector elements that are distributed in a layer or substrate. Typically the detector elements are
30 arranged in a regular, preferably rectangular raster. Every detector element corresponds to one picture element (pixel) of images generated by the X-ray detector. The detector

elements each comprise a sensor unit for the conversion of radiation into an electric signal. Moreover they comprise an electronic processing circuit coupled to the sensor unit for the postprocessing of the electric signals generated by the sensor unit. A shielding of variable shielding effectiveness (or shield factor) is arranged in front of the processing circuit or at least in front of regions of the processing circuit that have to be protected against X-radiation. In this context, the term "in front of" refers to the direction of incidence of X-rays. This means that the shielding is disposed on that side of the processing circuits which faces the X-radiation, e.g. on top of the processing units if X-radiation comes from above. Thus the X-radiation is absorbed in the shielding before it reaches vulnerable parts of the processing circuit. In contrast to known detectors, the shielding effectiveness is not the same in all places in front of the processing circuit, but variable. Thus it may be fitted to the locally needs of different regions of the processing circuit.

A varying shielding effectiveness may be achieved in different ways.

The shielding may for example be composed (continuously or discretely) of different materials with different absorption coefficients for X-rays. The choice of a certain material in a certain place of the shielding may in this case be based on its shielding effectiveness and other aspects like weight, processibility, price etc. Preferably a varying shielding effectiveness will however be achieved by a varying effective thickness of the shielding (which may of course be combined with in inhomogeneous shielding material). The "effective thickness" is defined and measured in this case as the geometrical thickness of the shielding in the direction of X-ray incidence. In contrast to known detectors, the effective thickness of the shielding is not the same in all places in front of the processing circuit, but variable. Thus it may be fitted to the locally needed shielding effectiveness of different regions of the processing circuit. In particular a minimal effective thickness of the shielding in front of each region of the processing circuit can be chosen such that the provided shielding is just sufficient. In this case the shielding occupies a minimal volume only, and absorption of X-rays that is not necessary for the protection of the electronics is avoided. This in turn maximises the yield of X-ray quanta that are detected by the sensor units.

In accordance with a preferred embodiment of the X-ray detector a scintillator unit is disposed in front of the sensor unit in each detector element. As

above, the term "in front of" is defined here with respect to the incidence of X-rays. The scintillator unit converts X-rays into photons of visible light that can be detected by photosensitive sensor units.

Preferably the scintillator units mentioned above and the shieldings of
5 the processing circuits are arranged together in a common layer without gaps between them. As the shielding can be reduced to a minimal volume due to its variable effective thickness, the volume of the scintillation material in turn can be maximised. Thus the yield of detected X-ray quanta is maximized.

The form or shape of the shielding can in principle be arbitrary.
10 Preferably the shielding is formed as a section (profile), i.e. a spatial form whose cross section is constant in one spatial direction. Sections can be produced comparatively simple and economical, for example by means of an extrusion process. Moreover it is possible to arrange sections continuously along the rows and/or columns of a matrix-shaped X-ray detector. In this case one section can provide the shielding for a
15 great number of detector elements.

In accordance with a preferred embodiment the section consists of a spatially shaped stripe of some shielding material. Such a section can be produced especially simply by bending a stripe that is initially flat into a desired spatial shape.

Moreover, the section can be L-shaped, i.e. have an L-shaped cross
20 section. The L-shape can particularly be achieved by bending a stripe of some shielding material.

Furthermore the section can be trapezoidal or triangular, i.e. have a trapezoidal/triangular cross section. A triangular cross section can be regarded as a special case of a trapezoidal section in this case (i.e. trapezoid with one side of length
25 zero). Due to the sloped sides of a trapezoid the effective thickness of the shielding changes continuously, thus implementing a continuously varying shielding effectiveness.

All materials that show a sufficiently high absorption coefficient for X-radiation of a given energy and that can be processed comparatively well can be used
30 as a material for the shielding. Particularly suited materials comprise lead (Pb), tungsten (W) molybdenum (Mo), tantalum (Ta), titanium (Ti) and/or other substances with high atomic weight (Z number). Moreover, salts like barium sulphate (BaSO₄), barium

carbonate (BaCO_3), barium oxide (BaO), lead carbonate (PbCO_3), lead chloride (PbCl_2), lead sulphate (PbSO_4), titanium oxide (TiO_2) and/or zinc oxide (ZnO) can be used in a shielding.

The shielding may consist exclusively of one of the materials mentioned
5 above or a composition (e.g. an alloy) of several of these materials. Alternatively at least one of the materials may be embedded in a carrier like a plastic or an epoxy-resin. In this case, the shielding effectiveness will be determined by the volume ratio between said material and the carrier.

The sensor unit of the detector elements can especially contain a
10 photodiode with which photons coming from a conversion material can be detected. Such a photodiode can particularly be implemented as an integrated CMOS-circuit (cf. US 6 292 528 B1, US 6 324 244 B1). Furthermore, the sensor units and the processing circuits may be arranged in a common substrate or layer, i.e. a "chip".

Moreover, the invention relates to an X-ray detector with detector
15 elements arranged in a layer or substrate, the X-ray detector comprising a layer of scintillator units disposed in front of a layer of sensor units. In this context the term "in front of" is again defined with respect to the incidence of X-rays. The scintillator units of the detector are separated from each other by a spacer or shielding that has a high shielding effectiveness with respect to X-rays and a high reflectivity with respect to
20 photons produced in the scintillator units. The shielding effectiveness may particularly be achieved by a shielding material with a high absorption coefficient for X-rays, e.g. like the absorption coefficient of Pb or W. Said reflectivity for photons may particularly be higher than 70 %, preferably higher than 90 %. The shielding may be a composite comprising a kernel material with high absorption coefficient for X-rays, e.g. barium
25 sulphate (BaSO_4), and a surface coating with a high reflectivity for photons, e.g. polyvinylidene fluoride (PVDF).

The proposed X-ray detector has the advantage to protect sensitive elements against potentially harmful X-rays and to prevent cross talk between different sensor units while maximising light output of the scintillator elements as light is
30 reflected back into the adjacent scintillator unit. The detector may preferably comprise all or some of the features of an X-ray detector of the kind described above, i.e. have a shielding of variable effectiveness for pixel electronics etc.

In the following the invention is described by way of example with the help of the accompanying drawings in which:

5 Fig. 1 a perspective view of a first embodiment of an X-ray detector with L-shaped shieldings;
 Fig. 2 is a side view of one detector element of the detector of figure 1;
 Fig. 3 is a side view of an alternative detector element for an X-ray detector.

10

 In figure 1 a part of an X-ray detector 10 is schematically represented in a perspective view. The X-ray detector 10 consists of a great number (typically several thousand) of detector elements 1 arranged in rows and columns, of which only 25 are depicted in the drawing. Every detector element 1 corresponds to a picture element (pixel) of images produced with the detector 10.

 As figure 2 shows more clearly, each of the detector elements 1 is built up in two layers. A (with respect to the direction of arrival of X-rays X) "backward" layer contains a photodiode 5 and a corresponding electronic processing circuit 4. The photodiode 5 and the circuit 4 can particularly be implemented in CMOS technology on
20 the same substrate. The layer left or (with respect to the direction of arrival of the X-rays X) "in front of" the photodiode 5 and the processing circuit 4 comprises a scintillation element or crystal 2 as well as a shielding 3. The scintillator element 2 consists of a suitable scintillation material as for example CdWO₄, GOS (Gd₂O₂S). It is
25 used for converting incident X-ray quanta X into photons v of visible light. Those photons v which reach the photodiode 5 generate an electric signal there. This electric signal is processed by the circuit 4 and read out in some manner that is known to the skilled artisan and must not be explained in more detail here.

 The shielding 3 is used for protecting the processing circuit 4 located
30 behind it against harmful and/or disturbing X-rays. For this purpose the shielding 3 is produced of a material with high absorption coefficient for X-radiation. A further function of the shielding 3 is to absorb and/or preferably to reflect photons v produced

in the scintillator element 2. In this way it is prevented that such photons γ reach the photodiodes of neighbouring detector elements, i.e. produce cross talk which would lead to an erroneous spatial assignment of the detected radiation and thus to a degraded image quality. A reflection of the photons back into the scintillation element 2 prevents
5 the photon from being lost for detection and thus maximises the light yield. Therefore, the surface reflectivity of the shielding 3 for visible light should be as high as possible.

The best shielding efficiency is achieved with heavy metals like lead, tungsten or molybdenum which are therefore particularly suited for the production of thin shielding foils. Moreover, compositions comprising a pulverized absorption
10 material embedded in a carrier like an epoxy resin may be used as shielding materials. In this case the absorption material may be a metal or a salt of a metal, the salts generally having the higher reflectivity with respect to photons. Preferably salts with a high density are used, for example: salts of barium like BaSO_4 (4,48 g/cm³, high reflectivity), BaCO_3 (4,43 g/cm³), BaO (5,7 g/cm³); salts of lead like PbCO_3
15 (6,56 g/cm³), PbCl_2 (5,9 g/cm³), PbSO_4 (6,2 g/cm³); TiO_2 (4,23 g/cm³) and/or ZnO (5,6 g/cm³). The shielding efficiency of a composition is primarily determined by the relative volume of the absorption material; for a high shielding efficiency, as little carrier as possible should be used.

When choosing a certain shielding material, the energy of the X-rays that
20 are to be absorbed should be taken into account, too. This is because different applications are characterised by different X-ray energies, typically ranging from about 20 keV in mammography to about 512 keV in positron emission tomography (PET), and because the absorption properties of a material depends on radiation energy. The following two tables list the remaining ratio of intensities I/I_0 (in photon numbers) of
25 different absorption and carrier materials for a thickness of $L_0 = 0.01$ cm of the material. This ratio depends exponentially on the thickness L and a function μ of the radiation energy E according to the following formula: $I/I_0 = \exp(-L \cdot \mu(E))$.

Energy [keV]	Pb	Mo	Ta	W	Ti
10	8.80733e-006	0.00105918	3.51564e-014	1.04286e-016	0.0203147
20	0.000165166	0.000712503	8.63839e-005	1.34059e-005	0.534991
30	0.0420859	0.0716168	0.0351068	0.0179467	0.814906
40	0.217721	0.28894	0.201375	0.145398	0.910887
50	0.420252	0.505349	0.404598	0.336544	0.94931
60	0.579369	0.658066	0.566167	0.504053	0.967289
70	0.690047	0.757304	0.177913	0.128645	0.976708
80	0.766647	0.823334	0.293375	0.232568	0.9823
90	0.448876	0.86633	0.400679	0.33645	0.985721
100	0.540656	0.896362	0.496976	0.434433	0.988006
120	0.673645	0.93165	0.640205	0.587107	0.990616
150	0.799025	0.95849	0.777602	0.740315	0.992644
300	0.955581	0.986055	0.949203	0.939841	0.995317
500	0.981927	0.991016	0.977775	0.97387	0.996315
1000	0.991989	0.994058	0.989124	0.987345	0.997348

Energy [keV]	Al	Fe	Polyethylene	Acrylic plastic	Teflon ®
10	0.581454	2.68923e-005	0.984978	0.968795	0.893457
20	0.921802	0.169747	0.996262	0.993674	0.981419
30	0.972331	0.555258	0.99755	0.996486	0.991717
40	0.98555	0.765368	0.997912	0.997236	0.994383
50	0.990421	0.863812	0.998077	0.997545	0.995409
60	0.992697	0.912931	0.998178	0.99772	0.995919
70	0.993895	0.939513	0.998253	0.997836	0.996221
80	0.994625	0.955436	0.998312	0.997922	0.99643
90	0.995097	0.965147	0.99836	0.99799	0.996587
100	0.995434	0.97166	0.998404	0.998048	0.996713
120	0.995875	0.979116	0.99848	0.998146	0.99691
150	0.99629	0.984774	0.998575	0.998265	0.997132
300	0.997196	0.9914	0.998872	0.998632	0.997737
500	0.997726	0.993406	0.999076	0.99888	0.998158
1000	0.998343	0.99529	0.999325	0.999182	0.998655

As not all regions of the processing circuit 4 require the same degree of protection from X-radiation, it is proposed to shape the shielding 3 with a varying effective thickness. Effective thickness (or shielding effectiveness) is defined and measured in this case in the direction of arrival of the X-rays X or, in other words,

orthogonal to the surface of the detector 10 (horizontal direction in the figures). In the embodiment represented in figures 1 and 2, the shielding 3 is for example formed as an L-shaped section or profile of thickness b . The branch 3b of the L contacting the processing circuit 4 has in this case an effective thickness $d1 = b$. The thickness b of the section is chosen high enough to prevent cross talk between neighbouring detector elements, while $d1$ (in this case the same as b) is the minimum size for efficient X-ray shielding of less sensitive electronics. The branch 3a of the L projecting transversally away from the processing circuit 4 on the other hand has a much greater effective thickness $d2$ in order to protect the regions of the processing circuit 4 located behind it with a much higher shielding effectiveness. Components of the processing circuit 4 that need such a high protection from X-radiation are for example sensitive analogue electronics, while components that require less protection and can be placed under the thinner branch 3b of the shielding 3 comprise e.g. "guarded capacitors" and the like. The dimensions b , $d1$, $d2$ of the shielding 3 have to be chosen as a best compromise between requirements regarding cross talk, X-ray shielding, reflection, and light output (scintillator volume).

The advantage of a shielding 3 of variable effective thickness is that its volume can be limited to the necessary minimum needed for a sufficient protection of the processing circuit 4. The volume saved (with respect to a simple cuboid-shaped shielding) in this way can then be filled by scintillation material of the scintillation element 2. Thus the X-ray quantum X shown in figure 2 would for example be absorbed by a cuboid-shaped shielding of constant thickness. With the L-shaped shielding 3 of the present embodiment, however, this quantum X is converted into a photon v in the scintillation material 2, the photon v being able to reach the photodiode 5 where it is detected. Therefore, the detector quantum efficiency (DQE) of the detector 10 is increased.

The production of an X-ray detector 10 according to figures 1 and 2 is comparatively simple since the shielding 3 can be produced by bending a stripe of lead. Moreover, a recess must be provided at the bottom of the scintillator element 2 in order to provide a space for the branch 3b of the shielding 3. This recess can e.g. be made by milling of an initially cuboid-shaped scintillation crystal. Alternatively, two cuboid-shaped scintillation crystals of different heights ($d2$ and $d2-d1$) could be glued together.

An alternative embodiment of the invention is shown in figure 3 which depicts a similar view of a single detector element 11 as figure 2. Same components as in figure 2 are provided with same reference signs and need not be explained again. The difference with respect to the embodiment of figures 1 and 2 is that the shielding 13 of the detector element 11 has the form of a wedge, i.e. a prism with triangular cross section. The thickness of the shielding 13 in front of the processing circuit 4 increases linearly from a minimum at the lower edge in figure 3 to a maximum at the upper edge in figure 3. The scintillator element 12 is complementarily shaped such that it joins in a gapless way with the shielding 13. This embodiment provides an increased volume for the conversion of X-ray quanta, too, while at the same time a sufficient protection of the electronics 4 is guaranteed.

The shapes of shieldings with varying effective thickness shown in the figures are of course only examples of possible embodiments. The skilled artisan will be able to modify them and find other shapes of varying effective thickness that provide a larger volume for the scintillator and at the same time a sufficient protection of the electronics. Moreover, it is possible to (re-)design circuits in a detector element in such a way that their components lie under those parts of a shielding of given shape that provide just enough protection against radiation.

CLAIMS:

1. X-ray detector (10) with detector elements (1, 11) arranged in a layer, wherein every detector element (1, 11) comprises a sensor unit (5) and a processing circuit (4) coupled thereto, and wherein a shielding (3, 13) of variable shielding effectiveness is disposed in front of the processing circuit (4).
5
2. X-ray detector (10) according to claim 1, characterized in that the shielding (3, 13) has a variable effective thickness (d1, d2).
3. X-ray detector according to claim 1, characterized in that a scintillator
10 unit (2, 12) is disposed in front of each sensor unit (5).
4. X-ray detector according to claim 3, characterized in that the scintillator unit (2, 12) and the shielding (3, 13) are arranged in a gapless way in a common layer.
- 15 5. X-ray detector according to claim 2, characterized in that the shielding is formed as a section (3, 13).
6. X-ray detector according to claim 5, characterized in that the section consists of a spatially shaped strip (3).
20
7. X-ray detector according to claim 5, characterized in that the section (3) is L-shaped.
8. X-ray detector according to claim 5, characterized in that the section (13)
25 is trapezoidal or triangular.

9. X-ray detector according to claim 1, characterized in that material of the shielding (3, 13) contains at least one of the following substances: Pb, W, Mo, Ta, Ti, BaSO₄, BaCO₃, BaO, PbCO₃, PbCl₂, PbSO₄, TiO₂ and/or ZnO.

5 10. X-ray detector according to claim 9, characterized in that said material is embedded in a carrier, preferably an epoxy-resin.

11. X-ray detector according to claim 1, characterized in that the sensor units (5) and the processing circuits (4) are arranged in a common layer.

10

12. X-ray detector (10) with detector elements (1, 11) arranged in a layer, preferably X-ray detector according to claim 1, comprising a layer of scintillator units (2, 12) disposed in front of a layer of sensor units (5), the scintillator units (2, 12) being separated from each other by a shielding (3, 13) that has a high shielding

15 effectiveness with respect to X-rays and a high reflectivity with respect to photons produced in the scintillator units (2, 12).

1/3

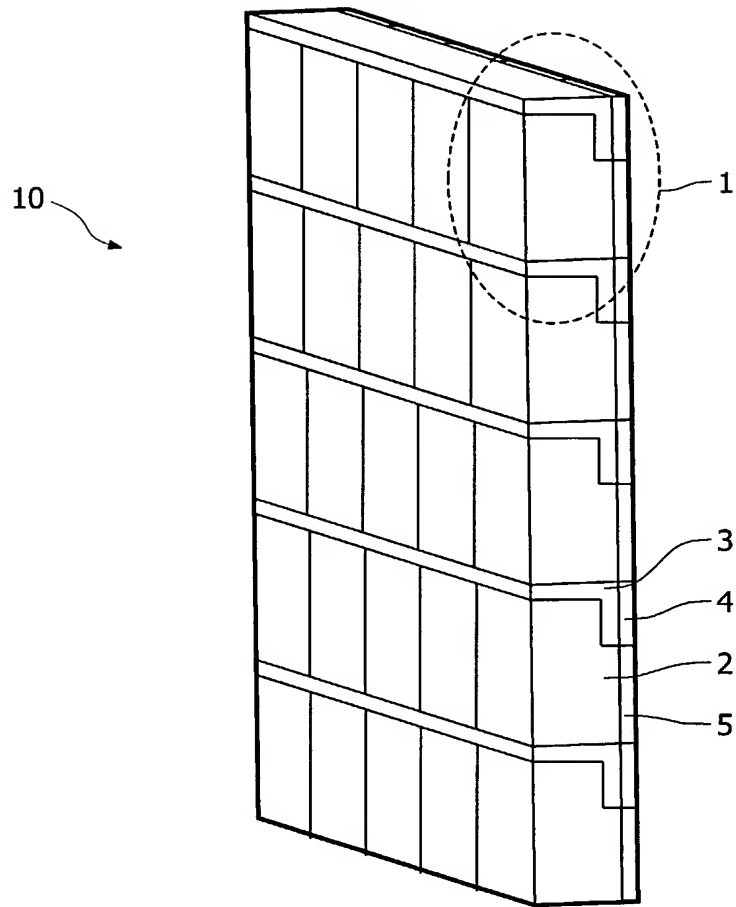


FIG. 1

2/3

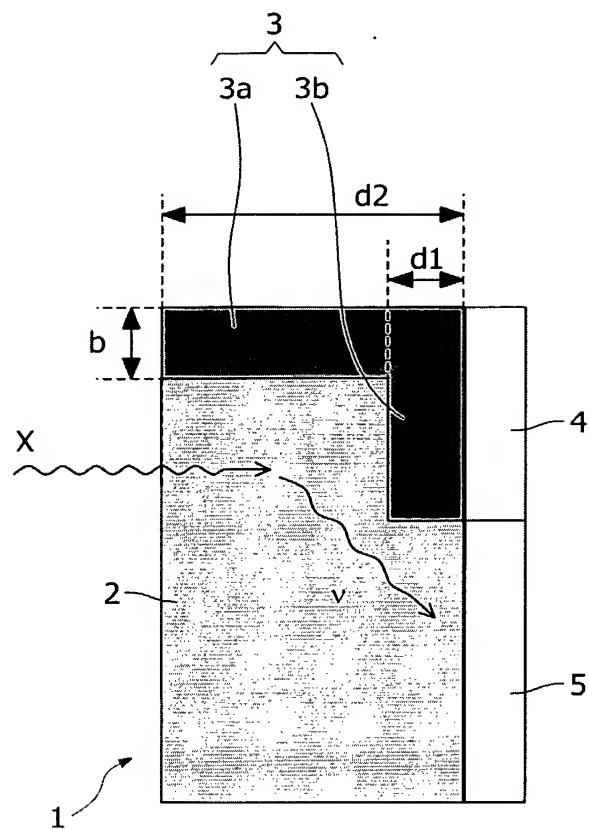


FIG. 2

3/3

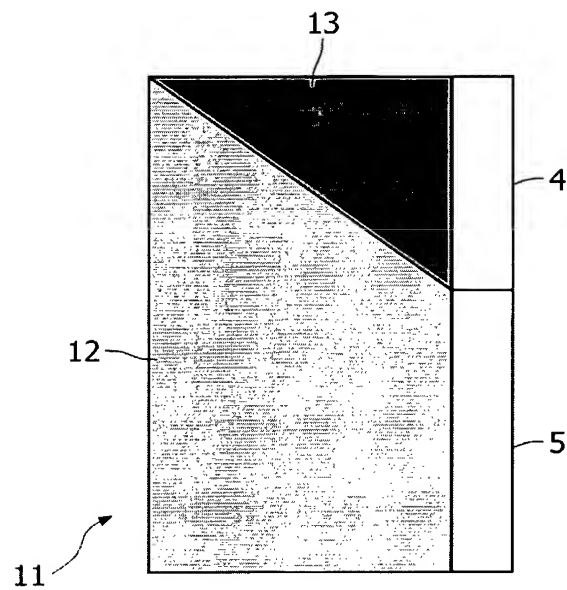


FIG. 3

INTERNATIONAL SEARCH REPORT

International Application No
PCT/IB2004/052640

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G01T1/20

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
IPC 7 G01T

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC, COMPENDEX, BIOSIS

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 2002/011572 A1 (KAJIWARA KENJI ET AL) 31 January 2002 (2002-01-31) page 3, paragraph 55 - page 8, paragraph 126; figures 1,3,4,7,11,12	1-3,5-10
Y		4,11
X	US 4 492 869 A (SUZUKI ET AL) 8 January 1985 (1985-01-08) column 2, line 29 - line 68 column 4, line 52 - column 9, line 41 figures 2,4,5,7	1,3,9
X	EP 1 089 091 A1 (HITACHI METALS, LTD) 4 April 2001 (2001-04-04) page 2, line 5 - page 3, line 24 figures 1,2	12
Y		4,11
	----- -/--	

☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

* Special categories of cited documents:

- *A* document defining the general state of the art which is not considered to be of particular relevance
- *E* earlier document but published on or after the international filing date
- *L* document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
- *O* document referring to an oral disclosure, use, exhibition or other means
- *P* document published prior to the international filing date but later than the priority date claimed

- *T* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- *X* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- *Y* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.
- *G* document member of the same patent family

Date of the actual completion of the international search

26 January 2005

Date of mailing of the international search report

03/02/2005

Name and mailing address of the ISA

European Patent Office, P.B. 5818 Patentlaan 2
NL - 2280 HV Rijswijk
Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,
Fax: (+31-70) 340-3016

Authorized officer

Coda, R

INTERNATIONAL SEARCH REPORT

In International Application No
PCT/IB2004/052640

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	US 4 845 363 A (AKAI ET AL) 4 July 1989 (1989-07-04) the whole document -----	12

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No
PCT/IB2004/052640

Patent document cited in search report		Publication date		Patent family member(s)	Publication date
US 2002011572	A1	31-01-2002	JP	2002116261 A	19-04-2002
US 4492869	A	08-01-1985	JP	1333593 C	28-08-1986
			JP	57070476 A	30-04-1982
			JP	60058430 B	19-12-1985
			DE	3141755 A1	08-07-1982
EP 1089091	A1	04-04-2001	JP	2001099941 A	13-04-2001
			US	6495845 B1	17-12-2002
US 4845363	A	04-07-1989	JP	62071881 A	02-04-1987